

# Port 111 – U11 – EUV Beamline

This beamline is PRT owned.

Current as of June 2012

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## Beamline

U11-EUV Beamline  
608-877-2000

## Manager

Paul Nealey  
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## Technical

<b>Energy Range</b>	92.5 eV Typical. Undulator defined 60 eV – 100 eV range.
<b>Focused Spot</b>	Spot size (horizontal x vertical) is 5 mm x 5 mm.
<b>Automation</b>	Automated exposure control and stepping
<b>Computer Interface</b>	
<b>Special Feature(s)</b>	Undulator beam, high vacuum exposure, 60 mm x 60 mm travel exposure stage.